Which SEM is right for me?

	JEOL	FEI
Training sessions:	2	3+
Common tasks:		
Secondary electron imaging	•	•
Backscatter electron Imaging	•	•
EDS (including mapping)	•	•
Imaging a large field of view	•	0
Sample tilting	$lue{ullet}$	•
I want to image features:		
> 50 μm	•	$lue{ullet}$
50 μm to 0.1 μm	•	•
< 0.1 μm	0	•
My samples are:		
> 5mm thick	•	0
< 75 mm wide	•	•
75 mm to 100 mm wide	0	•
Weigh > 200 g	•	0
Biological	•	-
Nonconductive	•	-
Magnetic	•	NA
Special applications:		
Low vacuum imaging	•	NA
Cathodoluminescence	•	NA
Focused ion beam (cross-sectioning)	NA	•
Gas injection deposition (Pt, W, Co, TEOS)	NA	•
Nanomanipulator	NA	•
STEM (including dark field)	NA	•

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→ Possible, may require additional sample preparation

O - Not recommended

NA - Not allowed / available